

FORM PTO-1449 (modified)
 To: U.S. Department of Commerce
 (PW FORM PAT-1449)
 Patent and Trademark Office

Atty. Dkt. No.	M#	Client Ref.
	306289	P-0370.101-US

**INFORMATION DISCLOSURE STATEMENT
 BY APPLICANT**

Applicant: Heine M. MULDER <i>et al.</i>	
Appln. No.: Not Yet Assigned	
Filing Date: October 15, 2003	
Examiner: Unknown	Group Art Unit: Unknown

Date: October 15, 2003 Page 1 of 1

U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR						
	BR						
	CR						
	DR						
	ER						
	FR						
	GR						
	HR						
	IR						
	JR						
	KR						
	LR						
	MR						
	NR						

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name		English Abstract		Translation Readily Available	
							Enclosed	No	Enclose	No
	OR									
	PR									
	QR									
	RR									
	SR									
	TR									
	UR									
	VR									
	WR									
	XR									

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	YR	Joseph P. Kirk, "Scattered Light in Photolithographic Lenses", Optical/Laser Microlithography VII (1994), SPIE Vol. 2197, pgs. 566-572			
	ZR				
	AAR				
	BBR				

Examiner Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.